INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 6, 2026

IGI Report Number	LG844650976
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL POLYGON STEP CUT
Measurements	10.67 X 6.69 X 3.98 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	E
Clarity Grade	VS 2

ADDITIONAL GRADING INFORMATION

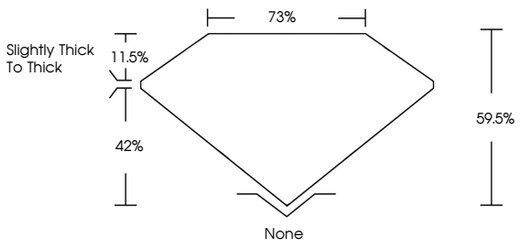
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG844650976

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG844650976

Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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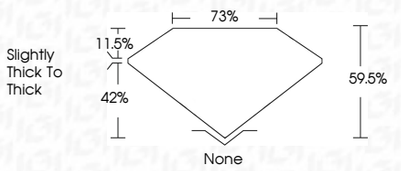
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IGI

October 6, 2026
IGI Report No LG844650976
OVAL POLYGON STEP CUT
10.67 X 6.69 X 3.98 MM
Carat Weight 2.01 CARATS
Color Grade E
Clarity Grade VS 2
Depth 59.5%
Table 73%
Girdle Slightly Thick To Thick
Culet None
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG844650976
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa